EV318284853

Inventor:

Li Li et al.

Title:

Processing Method of Forming MRAM Circuitry

Assignee:

Micron Technology, Inc.

INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is

directed to the United States patents and other references listed on the attached

Form PTO-1449. No admission is made regarding whether all the submitted

references are prior art.

The listed references were cited by, or submitted to, the Office in the

parent, co-pending application of the above-identified application. The above-

identified application is a divisional application of co-pending application Serial

No. 10/051,678, filed January 16, 2002. Such prior disclosure is sufficient for

the above-identified application as far as copies of the references are concerned.

37 C.F.R. § 1.98(d) and MPEP § 609(2).

Citation of these references is respectfully requested.

Respectfully submitted,

Dated:

11-21-63

By:

Mark S. Matkin

Reg. No. 32,268

SERIAL NO. ATTY. DOCKET NO. M122-2441 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE Filed Herewith Form PTO-1449 APPLICANT LIST OF ART CITED BY APPLICANT Li Li et al. (Use several sheets if necessary) GROUP FILING DATE Filed Herewith 2824 U.S. PATENT DOCUMENTS Filing Date Subclass Class If Appropriate Date Document *Examiner Initial Number 431 438 VANHAELEMEERSCH ET AL. 7/2003 6,599,814 AA 134 NGUYEN ET AL. 5/2003 6.569,257 698 428 NISHIOKA ET AL. 5/2002 6,387.551 AC BJORKMAN ET AL. **1/:002** 6.340,435 95 117 KITABATAKE 8/2001 6,273.950 AE ROBINSON ET AL. 5/2000 6,064,081 723 438 CUI ET AL. 10/1999 5,965,463 155 AG 438 SHANNON 11/1995 5,466,617 ΑH 35 378 MARUYAMA ET AL. 8/1994 5.335.256 427 TAY ET AL. 3/1994 5,296,258 167 438 FURUKAWA ET AL. 8/1992 5.135.885 2 ΑK BARTHA ET AL. 5/1992 5,116,462 483 AL438 MITO ET AL. 12/1991 5,070,027 81 264 BERTIN ET AL. 8/1999 4.861.533 FOREIGN PATENT DOCUMENTS Translation Subclass Country Yes Date Document Number AO ΑP OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.) ΑQ AR ΑT DATE CONSIDERED *EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. **EXAMINER**